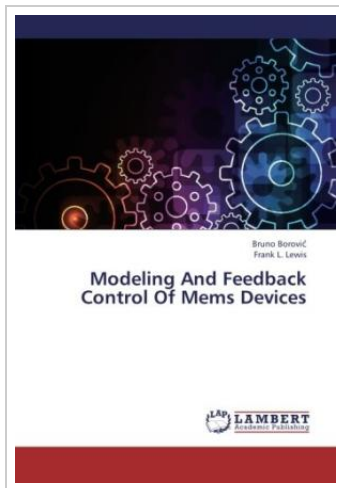




Modeling And Feedback Control Of Mems Devices

By Borovic, Bruno / Lewis, Frank L.

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